

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Serial No.: 10/675,419  
Art Unit: 1756  
Applicant: John M. Kulp  
Title: **SACRIFICIAL SURFACTANATED PRE-WET FOR DEFECT  
REDUCTION IN A SEMICONDUCTOR PHOTOLITHOGRAPHY  
DEVELOPING PROCESS**  
Attorney Docket: CT-001  
Confirmation No.: 6182

Cincinnati, OH

July 21, 2006

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT - AFTER NON-FINAL REJECTION**

This paper is responsive to the Office Action mailed February 21, 2006. The Examiner has indicated that claims 1-36 are pending in the application, claims 1-35 are rejected and claim 36 is withdrawn from consideration. The present response includes the following:

Amendments to the Specification:	None
Amendments to the Claims:	Pages 2-9
Amendments to the Abstract:	None
Amendments to the Drawings:	None
Remarks:	Pages 10-13
Attachments:	None